

AMENDMENTS TO THE SPECIFICATION

IN THE SPECIFICATION

Please replace the paragraph on page 2, lines 20-27 with the following:

According to an aspect of the present invention, an apparatus for measuring a gap between a mask and a substrate includes a laser displacement sensor, which is placed on a mask and a substrate spaced apart from each other by a predetermined gap, emits laser beams while moving ~~onto~~over the mask and the substrate in a horizontal direction and measures a gap between the mask and the substrate using a variation in distance values measured successively based on light-receiving positions of the laser beams that are reflected from the mask and the substrate ~~and return to their original positions~~, respectively.